

Electronic Acknowledgement Receipt

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Application Number:	10686486
International Application Number:	
Confirmation Number:	8014
Title of Invention:	Apparatus for electro chemical deposition of copper metallization with the capability of in-situ thermal annealing
First Named Inventor/Applicant Name:	Robin Cheung
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1	Notice of Appeal Filed	003421C2_EF.pdf	123671	no	2

Warnings:

Information:	Total Files Size (in bytes):	123671
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<u>New Applications Under 35 U.S.C. 111</u>		
If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.		
<u>National Stage of an International Application under 35 U.S.C. 371</u>		
If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.		